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** CONTINUING DATA ***** *ok*
This application is a CIP of 09/527,342 03/17/2000 PAT 6,528,751 *m*

** FOREIGN APPLICATIONS ***** *ok*
hm

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
** 03/18/2002

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY CA	SHEETS DRAWING 10	TOTAL CLAIMS 125	INDEPENDENT CLAIMS 12
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	EXAMINER'S SIGNATURE <i>[Signature]</i>	INITIALS <i>n</i>		

Verified and
Acknowledged

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32588
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TITLE
Plasma reactor with overhead RF electrode tuned to the plasma with arcing suppression